		Notice of Refer	ences Cited	Application No. 9-545549 Hounous Examiner Group Art Unit Geovae Goudreau 1763 Pa					ol, Los L
U.S. PATENT DOCUMENTS									
*		DOCUMENT NO.	DATE	NAME CLA				CLASS	SUBCLASS
	A	6,413,833	7-2-021	Vamamoto			438	398	
	В	C 232 628	5-15-01	Shirosaki et, al			257	306	
	c	(368913	4-9-621	Ü	imas	noto	· .	438	255
	D	0) 500) (13							
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	L								
	₩								
FOREIGN PATENT COCUMENTS									
*		DOCUMENT NO.	DATE	COUNTRY		NAM	Ε .	-CLASS	SUBCLASS
	М	11-238,863	8-31-99	ノゴる	pan	Son	<u></u>		
	0	09-636320	2-7-97	/		Uama	te		
	Р	11-097 641	4-9-99	1	Φ	Frank	ayuki		
	Q	, , , ,					0		
	R								
	s								
	T								
NON-PATENT DOCUMENTS									
*		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)							DATE
	U	"A New Cylindrical Capaciton using Hemisphenic							ol de
	•	et, ali ; International Electron Devices Meeting							gj
-	H	1112/ 12/201							
	W								
	x								

* A copy of this ref r nce is not being funished with this Office action. (See Manual of Patent Examining Procedur, Section 707.05(a).)

Part of Paper No.